

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	3	("2004/0104197").URPN.	USPAT	OR	ON	2010/08/18 10:01
L3	168	(mask with (tension\$4 taut \$4 constrict\$4 strain\$4 stress \$4 stretch\$4)) and (mask with (aperture hole slit)) and (electro\$luminescen\$3 EL LED OLED OLED light \$emitting light\$emission light \$emissive (light near3 (emitting emission emissive))) and (electrode anode cathode) and (mask with thin with (film layer))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/08/18 10:03
L5	403	("20010009689" "20010019807" "20020025406" "20020062785" "20020102754" "20020150674" "20030059690" "20030101932" "20030221613" "20030221614" "20040104197" "20040109153" "20040115342" "20040123799" "20040197675" "20050264177" "3241519" "3611069" "3647533" "3652895" "3769908" "3783353" "3840873" "3844005" "3875456" "3955021" "4167413" "4278528" "4365260" "4511599" "4577207" "4605942" "4615781" "4676193" "4715940" "4767962" "4780382" "4900584" "4915658" "4942333" "5059861" "5075743" "5077588" "5086250" "5144473" "5166761" "5231049" "5260151" "5294869" "5294870" "5315129"	US-PGPUB; USPAT; USOCR	OR	ON	2010/08/18 10:04

		"5318855" "5373786" "5391896" "5405710" "5409783" "5424560" "5429884" "5457565" "5478658" "5567267" "5652067" "5688551" "5804917" "5903246" "5998926" "6087196" "6097142" "6107736" "6146489" "6163352" "6177218" "6191433" "6373187" "6437495" "6437496" "6475287" "6489952" "6580212" "6611089" "6729927" "6749690" "6784459" "6858086").PN. OR ("2001/0004469" "2001/0019807" "2002/0025406" "2002/0059903" "2002/0062785" "2002/0102754" "2003/0101932" "2003/0111957" "2003/0201711" "2003/0221613" "2004/0115342" "2005/0264177" "5396145" "5707745" "6469439" "6611089" "6686693" "6784459" "6858086" "6893709" "6955726" "7285906" "7537798" "7572338"). URPN.				
L4	23	(dummy with (slit aperture hole)) with prevent\$4 with (deformation deform\$4)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/08/18 10:04
L6	500	((koji near1 shigemura) (chang near1 kang)).in.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/08/18 10:10
L11	36	(method manufacture manufacturing) same (OELD OLED (organic near1 electroluminescent)) same ((evaporation deposition) near1 mask) same electrode	US-PGPUB; USPAT; USOCR	OR	ON	2010/08/18 10:12

L13	152	WALFORD.XA.	USPAT	OR	ON	2010/08/18 10:55
L14	1	WALFORD.Xp.	USPAT	OR	ON	2010/08/18 10:57
L28	1	(10/717571).APP.	USPAT; USOCR	OR	ON	2010/08/18 11:29

EAST Search History (I nterference)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L10	3	((mask with (tension\$4 taut\$4 constrict\$4 strain\$4 stress\$4 stretch\$4)) and (mask with (aperture hole slit)) and (electro\$luminescen\$3 EL LED OELD OLED light\$emitting light \$emission light\$emissive (light near3 (emitting emission emissive))) and (electrode anode cathode) and (mask with thin with (film layer))). clm.	US-PGPUB; UPAD	OR	ON	2010/08/18 10:11
L9	1	((dummy with (slit aperture hole)) with prevent\$4 with (deformation deform\$4)).clm.	US-PGPUB; UPAD	OR	ON	2010/08/18 10:11
L8	74	((koji near1 shigemura) (chang near1 kang)).in. and mask	US-PGPUB; UPAD	OR	ON	2010/08/18 10:11
L7	204	((koji near1 shigemura) (chang near1 kang)).in.	US-PGPUB; UPAD	OR	ON	2010/08/18 10:11
L12	3	((method manufacture manufacturing) same (OELD OLED (organic near1 electroluminescent)) same ((evaporation deposition) near1 mask) same electrode). clm.	US-PGPUB; UPAD	OR	ON	2010/08/18 10:51

8/ 18/ 2010 11:49:57 AM**C:\ Documents and Settings\ nwalford\ My Documents\ EAST\ Workspaces\ 10718640.wsp**